

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

ADDI ICAN	T: TSUTOMU YAMADA ET AL.	)	
AI I LICAN	1. 130 TOMO TAWADA DI AD.	) Group Art Unit:	2812
SERIAL NO	0.: 09/966,692	)	
		) Before the Examin	ier:
FILED:	September 28, 2001	) S. Mulpuri	
		)	
FOR:	METHOD OF ATTACHING LAYER	)	
	MATERIAL AND FORMING LAYER	)	
	IN PREDETERMINED PATTERN ON	)	Œ
	SUBSTRATE USING MASK	)	ECHNOLOGY
			80
			,00
			27
			~

## **AMENDMENT**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed June 24, 2003, Applicants request reconsideration in view of the following amendment and remarks for entry in the above-identified application.

I hereby certify that this correspondence was mailed via First Class Mail and addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

> December 19, 2003 (Date of Deposit)

Agatha Skierkowski

(Name of Person Mailing Pape

2/19

12/30/2003 ZJUHAR1 00000078 09966692

03 FC:1202

36.00 OP

YKI-0078 09/966,692